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		Document ID	Issue Date	Pages	Title	Current OR	Current XRef	Retrieval Cl	Inventor	S	C	P
1	<input type="checkbox"/>	US 5990619 A	19991123	10	Electrode structures for plasma addressed liquid crystal	313/584	313/622; 345/60;		Ilcisin, Kevin J. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
2	<input type="checkbox"/>	US 5453660 A	19950926	20	Bi-channel electrode configuration for an addressing	313/582	313/631; 315/169.4;		Martin, Paul C. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
3	<input type="checkbox"/>	US 6559516 B1	20030506	25	Antifuse structure and method of making	257/530	257/50		Van Brocklin, Andrew L. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
4	<input type="checkbox"/>	US 6356248 B1	20020312	19	Spacers for use in an electro-optical addressing	345/60	345/87		Martin, Paul C. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
5	<input type="checkbox"/>	US 6330043 B1	20011211	15	Liquid crystal display device and method of fabrication TFT	349/43	349/106; 349/138		Kikkawa, Hironori et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
6	<input type="checkbox"/>	US 6317108 B1	20011113	25	Electrostatic video display drive circuitry and displays	345/85	340/905; 340/907;		Kalt, Charles G.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
7	<input type="checkbox"/>	US 6075247 A	20000613	7	Device for reading an imaging sensor matrix	250/370.09	250/370.08		Wieczorek, Herfried K. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
8	<input type="checkbox"/>	US 6057814 A	20000502	26	Electrostatic video display drive circuitry and displays	345/58	345/31; 345/85;		Kalt, Charles G.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
9	<input type="checkbox"/>	US 5956002 A	19990921	12	Structures and methods for limiting current in ionizable	345/60	345/66		Martin, Paul C. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
10	<input type="checkbox"/>	US 5917284 A	19990629	13	Sputter-resistant conductive coatings with enhanced emission	313/586	313/491; 313/584;		Moore, John S. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
11	<input type="checkbox"/>	US 5852427 A	19981222	11	Reducing cross talk effects in electro-optical addressing	345/97	345/208		Buzak, Thomas S.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
12	<input type="checkbox"/>	US 5783906 A	19980721	9	Sputter-resistant, low-work-function, conductive	313/586	313/584; 345/60;		Moore, John S. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
13	<input type="checkbox"/>	US 5623276 A	19970422	20	Kicker pulse circuit for an addressing structure using an	345/60	345/84; 345/87		Moore, John S. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
14	<input type="checkbox"/>	US 5528109 A	19960618	18	Addressing structure using ionizable gaseous mixture	315/169.4	313/582; 313/584;		Ilcisin, Kevin J. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
15	<input type="checkbox"/>	US 5471228 A	19951128	18	Adaptive drive waveform for reducing crosstalk effects in	345/58	345/60; 345/87		Ilcisin, Kevin J. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
16	<input type="checkbox"/>	US 5414440 A	19950509	16	Electro-optical addressing structure having reduced	345/58	345/100; 345/60;		Ilcisin, Kevin J. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
17	<input type="checkbox"/>	US 5400046 A	19950321	18	Electrode shunt in plasma channel	345/58	315/169.4; 345/60;		Ilcisin, Kevin J. et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
18	<input type="checkbox"/>	US 5276384 A	19940104	16	Electrode configuration for channel confinement of plasma	313/582	313/517; 315/169.4		Martin, Paul C.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
19	<input type="checkbox"/>	US 5272472 A	19931221	16	Apparatus for addressing data storage elements with an	345/60	315/116		Buzak, Thomas S.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
20	<input type="checkbox"/>	US 5225364 A	19930706	9	Method of fabricating a thin-film transistor matrix for	438/158	204/192.17; 257/829.151;		Nonoto, Tsutomu et al.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>
21	<input type="checkbox"/>	US 5077553 A	19911231	20	Apparatus for and methods of addressing data storage	345/87	345/60		Buzak, Thomas S.	<input checked="" type="checkbox"/>	<input type="checkbox"/>	<input type="checkbox"/>